

**CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)**

Applicant(s): Jifa Hao, et al.

Docket No.

90065.99R272/17732.6323

Serial No.  
09/654,845Filing Date  
September 1, 2000Examiner  
Ori NadavGroup Art Unit  
2811**Invention: POWER SEMICONDUCTOR DEVICE WITH HIGH AVALAN CHE CAPABILITY AND PROCESS  
FOR FORMING SAME**I hereby certify that this Amendment (total 4 pages)

(Identify type of correspondence)

is being deposited with the United States Postal Service as first class mail in an envelope addressed to:

Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on December 12, 2003  
(Date)Kathleen A. Manczuk

(Typed or Printed Name of Person Mailing Correspondence)

Kathleen A. Manczuk  
(Signature of Person Mailing Correspondence)

Note: Each paper must have its own certificate of mailing.

RECEIVED  
DEC 29 2003

TECHNOLOGY CENTER 2800